S/N 10/565716

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

MURAKAMI, ET AL.

Examiner:

HA, NGUYEN T

- Serial No.:

10/565716

Group Art Unit:

2831

Filed:

January 25, 2006

Docket No.:

20162.0012USWO

Title:

METHOD FOR FORMING OXIDE FILM ON METAL SURFACE USING IONIC LIQUID, ELECTROLYTIC CAPACITOR AND ELECTROLYTE

THEREOF

CERTIFICATE UNDER 37 CFR 1.6(d):

I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on March 17.

PETITION FOR EXTENSION OF TIME

Mail Stop: AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. §1.136(a), it is respectfully requested that a one-month extension of time be granted in which to respond to the outstanding Office Action mailed November 24, 2009, said period of response being extended from February 24, 2010 to March 24, 2010.

Please charge Deposit Account No. 50-3478 in the amount of \$130.00 to cover the required extension fee for a large entity.

Respectfully submitted,

52835

HAMRE, SCHUMANN, MUELLER & LARSON, P.C. P.O. Box 2902

Minneapolis, MN 55402-0902 (612) 455-3800

Dated: March 7, 2010

By:

Douglas P. Mueller

Reg. No. 30,300

DPM/ils

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